



# PHILIPS

## Philips Semiconductors

June 23, 1997

Ms. Susan Hoines  
Hazardous & Radioactive Materials Bureau  
New Mexico Environment Department  
2044 Galisteo  
P.O. Box 26110  
Santa Fe, NM 87502



Certified Mail: Z 729 721 018

Subject: Installation of New Solvent Waste Storage Tank (TA3)

Dear Ms. Hoines:

This letter is to inform you that the replacement tank for Tank TA3 has been contracted and is scheduled for installation on July 18, 1997. This will mean the existing tank will be in operation slightly longer than the 18 months recommended as a result of an inspection done in December of 1995. This inspection concluded that the tank welds contained defects resulting from poor manufacturing, and it was recommended that the tank be replaced within 18 months, i.e. by June 26 of 1997.

A detailed ultrasonic inspection of Tank TA3 was performed on February 11, 1997, and found that the defects detected during the previous inspection have not propagated or corroded to a detectable degree. This inspection report was sent to you on February 28, 1997.

Based on the inspection done in February of this year, we are confident that we can operate Tank TA3 safely until the installation of the new tank on July 18, 1997.

If you have any questions about the tank replacement, please contact me at (505) 822-7634.

Sincerely,

Joe Mauser, P.E.  
Environmental Supervisor  
(ENV721)

cc: John Tymkowych, NMED

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a North American Philips Company  
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*Handwritten initials and date: 10/20/97*

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